

Docket No.: 063979-0028



*IFM AF*

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: NISHIKAWA, TAKASHI, et al.

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE

Application No.: 10/616,917

Customer No.: 20277  
Confirmation No.: 2411

Filed: July 11, 2003

Group Art Unit: 2822

Examiner: Kiesha L. Rose

Title: A SEMICONDUCTOR DEVICE AND A FABRICATION METHOD THEREOF

**RESPONSE UNDER 37 CFR 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated July 27, 2005, having a three-month shortened statutory period for response set to expire October 27, 2005, reconsideration of the above-identified application is respectfully requested in view of the following remarks.